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	B1		2-(omega-alkoxycarbonylalkanoyl)-4- butanolides omega-hydroxy-(omega-3)-keto fatty esters, and derivatives thereof		554/205	Hideaki et al.
1	US 6261144 B1	20010717	Wiring substrate and gas discharge display device and method therefor	445/24	216/102; 216/23; 438/754; 445/46	Nishiki; Masashi et al.
1	US 6258759 B1	20010710	Metal working water and metal working composition	508/143	508/161; 508/173; 508/180	Futahashi; Sadao et al.
1	US 6242391 B1	20010605	Water-soluble cutting fluid	508/180	508/154; 72/42	Fukutani; Yasuo et al.
1	US 6204552 B1	20010320	Semiconductor device	257/666	257/676; 257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051; 257/E23.056; 257/E23.124; 257/E25.023; 257/E29.022	Murakami; Gen et al.
1	US 6197603 B1	20010306	Semiconductor device and manufacturing method thereof including a probe test step and a burn-in test step	438/14	438/113; 438/17; 438/33; 438/460	Kohno; Ryuji et al.
1	US 6142306 A	20001107	Carrier band of electronic parts	206/713	206/460; 206/714	Mori; Kazuhiro et al.
1	US 6130114 A	20001010	Semiconductor device	438/123	257/E23.039; 257/E23.051; 438/113; 438/118; 438/124; 438/125; 438/126; 438/127; 438/460	Murakami; Gen et al.
1	US 6124629 A	20000926	Semiconductor device including a resin sealing member which exposes the rear surface of the sealed semiconductor	257/666	257/676; 257/787	Murakami; Gen et al.

			chip			
1	US 6124553 A	20000926	Multilayer wiring board having vent holes and method of making	174/260	174/35R; 174/52.4; 257/E23.062; 257/E23.063; 257/E23.07	Narizuka; Yasunori et al.
1	US 6110291 A	20000829	Thin film forming apparatus using laser	118/726	427/596	Haruta; Kenyu et al.
1	US 6100580 A	20000808	Semiconductor device having all outer leads extending from one side of a resin member	257/666	257/676; 257/691	Murakami; Gen et al.
1	US 6100115 A	20000808	Semiconductor device	438/127	438/121; 438/123; 438/124; 438/125; 438/126	Murakami; Gen et al.
1	US 6087527 A	20000711	Method for producing alkyl carboxylates by multi-stage esteridication interrupted with a dehydration step	560/190	560/129; 560/231; 560/76; 560/8; 560/96	Niwa; Atsushi et al.
1	US 6081023 A	20000627	Semiconductor device	257/666	257/676; 257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051; 257/E23.056; 257/E23.124	Murakami; Gen et al.
1	US 6072231 A	20000606	Semiconductor device	257/666	257/668; 257/676; 257/691; 257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051; 257/E23.056; 257/E23.124; 257/E25.023; 257/E29.022	Murakami; Gen et al.
1	US 6069029 A	20000530	Semiconductor device chip on lead and lead on chip manufacturing	438/123	257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051; 257/E23.056; 257/E23.124;	Murakami; Gen et al.

					257/E25.023; 257/E29.022; 438/118; 438/119; 438/124; 438/127	
1	US 6057372 A	20000502	Antibacterial agents and cosmetics and clothing containing the same	514/675	514/680; 514/685; 514/859	Nobuhiro; Akio et al.
1	US 6051778 A	20000418	Electrode structure, process production thereof and photo-electricity generating device including the electrode	136/256	136/243; 136/244; 257/459; 257/753; 427/58; 427/74; 429/111; 429/212; 429/217; 429/232; 438/119; 438/83; 438/98	Ichinose; Hirofumi et al.
1	US 6051116 A	20000418	Etching apparatus	204/212	204/224M; 204/225; 204/288.1; 204/297.02	Ichinose; Hirofumi et al.
1	US 6033741 A	20000307	Thin film forming apparatus using laser	427/596	118/726	Haruta; Kenyu et al.
1	US 6030536 A	20000229	Disposal method for fuel oil and crude oil spills	210/671	204/514; 205/696; 210/680; 210/691; 210/763; 210/924; 210/925	Wada; Yukio et al.
1	US 6018191 A	20000125	Semiconductor device	257/691	257/670; 257/673; 257/692; 257/696; 257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051; 257/E23.056; 257/E23.124; 257/E25.023;	Murakami; Gen et al.

					257/E29.022	
1	US 6008451 A	19991228	Photovoltaic device	136/256		Ichinose; Hirofumi et al.
1	US 5993637 A	19991130	Electrode structure, electrolytic etching process and apparatus	205/652	204/224M; 204/272; 204/273; 204/289; 204/292; 204/293; 204/294; 205/656; 205/658; 205/659; 205/671; 205/674	Hisamatsu; Masaya et al.
1	US 5981315 A	19991109	Semiconductor device	438/127	257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051; 257/E23.056; 257/E23.124; 257/E25.023; 257/E29.022; 438/124; 438/126	Murakami; Gen et al.
1	US 5958600 A	19990928	Circuit board and method of manufacturing the same	428/458	174/257; 174/258; 174/260; 174/261; 257/E23.072; 257/E23.077; 428/209; 428/473.5; 428/901; 430/14; 430/15; 430/16; 430/18; 430/313; 430/317; 430/319; 528/353	Sotokawa; Hideo et al.
1	US 5942048 A	19990824	Photovoltaic element electrode structure thereof and process for	136/256	136/244; 257/459; 257/E31.042;	Fujisaki; Tatsuo et al.

			producing the same		438/98	
1	US 5919769 A	19990706	Fucose derivatives, drugs containing the same as active ingredient, and intermediates for producing the same	514/25	536/17.2	Tsukida; Takahiro et al.
1	US 5914530 A	19990622	Semiconductor device	257/666	257/659; 257/676; 257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051; 257/E23.056; 257/E23.124; 257/E25.023; 257/E29.022	Murakami; Gen et al.
1	US 5863817 A	19990126	Semiconductor device	438/124	257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051; 257/E23.056; 257/E23.124; 257/E25.023; 257/E29.022; 438/106; 438/126; 438/127	Murakami; Gen et al.
1	US 5863412 A	19990126	Etching method and process for producing a semiconductor element using said etching method	205/652	205/656; 205/659; 205/674; 205/685	Ichinose; Hirofumi et al.
1	US 5861324 A	19990119	Method for producing photovoltaic element	438/119	136/256; 257/E31.126; 438/57; 438/98	Ichinose; Hirofumi et al.
1	US 5859397 A	19990112	Process for the production of a photovoltaic element	204/157.15	205/687; 205/724; 205/766; 205/769; 257/E31.042	Ichinose; Hirofumi et al.
1	US 5821606 A	19981013	Semiconductor device	257/666	257/659; 257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051;	Murakami; Gen et al.

					257/E23.056; 257/E23.124; 257/E25.023; 257/E29.022	
1	US 5793099 A	19980811	Semiconductor device	257/666	257/676; 257/776; 257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051; 257/E23.124; 257/E25.023; 257/E29.022	Murakami; Gen et al.
1	US 5759291 A	19980602	Photovoltaic cell and method of making the same	136/256	257/459; 438/98	Ichinose; Hirofumi et al.
1	US 5688366 A	19971118	Etching method, method of producing a semiconductor device, and etchant therefor	438/754	136/244; 136/256; 252/79.1; 252/79.4; 257/E21.23; 257/E21.304; 438/57	Ichinose; Hirofumi et al.
1	US 5681402 A	19971028	Photovoltaic element	136/256	257/459; 257/753; 257/E31.126	Ichinose; Hirofumi et al.
1	US 5678167 A	19971014	Method for dissolving nuclear fuels	423/20	204/157.15; 423/658.3	Wada; Yukio et al.
1	US 5677393 A	19971014	Heat-resistant film adhesive for use in fabrication of printed circuit boards and process for using the same	525/423	156/329; 156/330; 428/413; 428/447; 428/473.5; 428/901	Ohmori; Fumihito et al.
1	US 5650051 A	19970722	Hydrogen generating method using gamma rays	204/157.52		Wada; Yukio et al.
1	US 5622567 A	19970422	Thin film forming apparatus using laser	118/726	427/596; 505/732	Kojima; Kazuyoshi et al.
1	US 5614805 A	19970325	Method and apparatus for charging a secondary battery by supplying pulsed current as charging current	320/139		Momotani; Hiroshi et al.
1	US 5612569	19970318	Semiconductor device	257/666	257/783;	Murakami;

	A				257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051; 257/E23.056; 257/E23.124; 257/E25.023; 257/E29.022	Gen et al.
1	US 5609807 A	19970311	Production of ceramic structural bodies	264/177.11	264/177.12; 264/211.11; 264/631	Wada; Yukihisa et al.
1	US 5585043 A	19961217	Method of coextracting neptunium and plutonium	252/636	204/157.4; 204/158.2; 423/10; 976/DIG.279	Wada; Yukio et al.
1	US 5583387 A	19961210	Stator of dynamo-electric machine	310/217	174/DIG.20; 310/254; 310/42	Takeuchi; Manabu et al.
1	US 5545484 A	19960813	Heat and oxidation resistive high strength material and its production method	428/408	428/469; 428/697; 428/698; 428/699; 428/701; 428/702	Yamaguchi; Shizuka et al.
1	US 5530286 A	19960625	Semiconductor device	257/692	257/666; 257/693; 257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051; 257/E23.056; 257/E23.124; 257/E25.023; 257/E29.022	Murakami; Gen et al.
1	US 5518711 A	19960521	X-ray contrast medium comprising barium and xanthan gum for examination of large intestine and small intestine	424/9.411	424/709; 514/54	Tonariya; Yoshito et al.
1	US 5503812 A	19960402	Method for separating and purifying fission noble metals	423/2	210/682; 423/22	Kirishima; Kenji et al.
1	US 5500192 A	19960319	Method of separating neptunium and plutonium	423/10	204/157.4; 204/158.2; 210/682;	Wada; Yukio et al.

					976/DIG.279	
1	US 5476726 A	19951219	Circuit board with metal layer for solder bonding and electronic circuit device employing the same	428/643	257/E23.072; 428/209; 428/668; 428/669; 428/671; 428/901	Harada; Masahide et al.
1	US 5465849 A	19951114	Column and method for separating particles in accordance with their magnetic susceptibility	209/214	209/223.1; 209/225; 209/232; 210/222	Wada; Yukio et al.
1	US 5448198 A	19950905	Semiconductor integrated circuit device having circuitry for limiting forward junction current from a terminal	327/530	257/E27.11; 326/72; 326/81; 327/534	Toyoshima; Yoshiaki et al.
1	US 5358904 A	19941025	Semiconductor device	29/827	257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051; 257/E23.056; 257/E23.124; 257/E25.023; 257/E29.022; 438/118; 438/123; 438/124	Murakami; Gen et al.
1	US 5343085 A	19940830	Power-on reset system and a semiconductor memory device incorporating same	327/143	327/217; 377/20	Fujimoro; Takuya et al.
1	US 5320729 A	19940614	Sputtering target	204/298.13	204/298.12; 423/326; 501/53	Narizuka; Yasunori et al.
1	US 5316710 A	19940531	Process for producing ceramic honeycomb structural bodies	264/630	264/671; 432/258	Tasaki; Yuji et al.
1	US 5285016 A	19940208	Wiring board provided with a heat bypass layer	174/252	257/E23.105; 257/E23.169; 361/688	Narizuka; Yasunori et al.
1	US 5267396 A	19931207	Plunger lead machining process for fuel injection pumps	29/888.04	29/888.02; 29/890.128	Wada; Yukio et al.
1	US 5265346 A	19931130	Drying carrier adapted for carrying honeycomb structure	34/250	34/105; 34/68	Jikumaru; Sueharu et al.



1	US 5262102 A	19931116	Process for firing ceramic honeycomb structural bodies	264/631		Wada; Yukihisa
1	US 5235313 A	19930810	Thin film resistor and wiring board using the same	338/308	204/192.1; 338/309; 427/101; 438/384	Narizuka; Yasunori et al.
1	US 5218335 A	19930608	Electronic circuit device having thin film resistor and method for producing the same	338/308	204/192.21; 338/223; 338/225	Nakano; Asao et al.
1	US 5191708 A	19930309	Manufacturing method of a probe head for semiconductor LSI inspection apparatus	29/846	216/11; 216/41; 29/825	Kasukabe; Susumu et al.
1	US 5183652 A	19930202	Radioactive catalyst and oxidation-reduction method and apparatus using same	423/579	422/159; 422/211; 423/658.2; 423/659	Sasao; Nobuyuki et al.
1	US 5160724 A	19921103	Barium sulfate contrast medium for X-ray examination of the large intestine	424/9.411	424/677; 514/966; 514/975	Tonariya; Yoshito et al.
1	US 5149264 A	19920922	Method of producing ceramic products	432/2	432/258; 432/259; 432/5	Horikawa; Osamu et al.
1	US 5110515 A	19920505	Method of encapsulating semiconductor chips	264/493	257/E21.504; 264/236; 264/272.13; 264/272.17	Nakamura; Shozo et al.
1	US 5093302 A	19920303	Radioactive catalyst and oxidation-reduction method and apparatus using same	502/325	252/625; 502/339; 502/350; 502/5	Sasao; Nobuyuki et al.
1	US 5068712 A	19911126	Semiconductor device	257/689	257/676; 257/686; 257/687; 257/786; 257/E23.039; 257/E23.048; 257/E23.049; 257/E23.051; 257/E23.056; 257/E23.124; 257/E25.023; 257/E29.022	Murakami; Gen et al.

1	US 5058063 A	19911015	Nonvolatile semiconductor memory device incorporating level shifting circuits	365/185.18	365/185.06; 365/185.28; 365/185.29; 365/189.11; 365/226	Wada; Yukio et al.
1	US 5058062 A	19911015	Nonvolatile semiconductor memory circuit including a reliable sense amplifier	365/185.21	365/185.06; 365/185.32; 365/189.05	Wada; Yukio et al.
1	US D316481 S	19910430	Case	D6/631		Kunimune; Noriaki et al.
1	US D315982 S	19910409	Case	D6/631		Kunimune; Noriaki et al.
1	US 4988529 A	19910129	Milk shake and manufacturing method thereof	426/569	426/565; 426/590; 426/592	Nakaya; Tsunemoto et al.
1	US 4970409 A	19901113	Voltage multiplier for nonvolatile semiconductor memory	327/541	307/110; 327/315; 363/60; 365/189.11; 365/226	Wada; Yukio et al.
1	US 4952272 A	19900828	Method of manufacturing probing head for testing equipment of semiconductor large scale integrated circuits	216/11	205/666; 205/683; 216/20; 216/57	Okino; Hironobu et al.
1	US 4931726 A	19900605	Apparatus for testing semiconductor device	324/754	439/482	Kasukabe; Susumu et al.
1	US 4912749 A	19900327	Nonvolatile semiconductor memory	365/185.18	257/321; 365/185.02; 365/185.06; 365/185.21; 365/185.25; 365/185.29	Maruyama; Tadashi et al.
1	US 4892189 A	19900109	Case for multiple compact disks	206/232	206/308.1; 206/309; 220/847; D6/626	Kunimune; Noriaki et al.
1	US 4870615 A	19890926	Nonvolatile floating gate semiconductor memory device	365/185.06	257/321; 257/E27.103; 365/185.14; 365/185.2; 365/185.25	Maruyama; Tadashi et al.
1	US 4806725 A	19890221	Circuit substrate and thermal printing head	347/203	338/307; 347/208;	Narizuka; Yasunori et

			using the same		420/457	al.
1	US 4681645 A	19870721	Method and apparatus for fusing together the bottom of tubular container formed of synthetic resin	156/73.1	156/304.5; 156/535; 156/580.2; 264/296; 264/320; 53/479; 53/484	Fukushima; Shoji et al.
1	US 4430808 A	19840214	Hair dryer	34/97	132/116; 34/101; 392/473	Toyomi; Yuritsugu et al.
1	US 4423856 A	19840103	Controlled cooling apparatus for hot rolled wire rods	266/106	266/111; 72/201	Takahashi; Eiji et al.
1	US 4370544 A	19830125	Hair dryer	392/379	200/50.28; 34/96; 392/385; D28/13	Fujishima; Nobuiti et al.
1	US 4343986 A	19820810	Thermal printhead	347/204	219/543; 257/E49.004; 338/309	Mitani; Masao et al.
1	US 4268614 A	19810519	Method of making printed circuit board	430/315	430/319; 430/327	Ueyama; Tamotsu et al.
1	US 4246398 A	19810120	Method for recovering polyphenylene oxides	528/496	528/495; 528/499	Sugio; Akitoshi et al.
1	US 4040696 A	19770809	Electric device having rotary current collecting means	439/23	219/225; 219/533; D28/35	Wada; Yukio et al.
1	US 4023392 A	19770517	Method and apparatus for cooling hot rolled rod	72/201	140/2; 266/106	Fujita; Tatsu et al.
1	US 3889693 A	19750617	Electric hair dryer with spray	132/272	D28/13	Tanaka; Hisayuki et al.
1	US 3858591 A	19750107	HAIR-PIECE FOR A HAIR WIG HAVING AN ALL DIRECTIONAL CONTRACTILITY AND ITS PROCESSING METHOD FOR THE SAME	132/53		Wada; Yukio
1	US 3846047 A	19741105	FOLDABLE HAIR DRYER	417/234	34/201; 34/97; 392/380;	Wada; Yukio et al.

					392/385; 415/126; D28/16	
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